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**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\****JD***\*\* FOREIGN APPLICATIONS \*\*\*\*\****JD***IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*****\*\* 03/22/2002**

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>JD</i> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 2
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**TITLE**

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